

Electronic Acknowledgement Receipt

EFS ID:	1221273
Application Number:	10585522
Confirmation Number:	4528
Title of Invention:	Process for producing soi wafer
First Named Inventor:	Hiroji Aga
Customer Number:	23581
Filer:	Anton E. Skaugset
Filer Authorized By:	
Attorney Docket Number:	SHX 367
Receipt Date:	26-SEP-2006
Filing Date:	
Time Stamp:	20:06:22
Application Type:	U.S. National Stage under 35 USC 371
International Application Number:	

Payment information:

Submitted with Payment	no
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File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1		TRAN_SUB_SUPP_IDS_SHX367.pdf	143642	yes	4

	Multipart Description		
	Doc Desc	Start	End
	Transmittal letter	1	1
Information Disclosure Statement (IDS) Filed		2	4
Warnings:			
Information:			
Total Files Size (in bytes):		143642	
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